

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
OSMI *et al.*

Confirmation No. 4482

Application No.: 09/866,576

Filed: May 29, 2001

ART UNIT: 2811

Title: SEMICONDUCTOR DEVICE FORMED ON (111)  
SURFACE OF A Si CRYSTAL AND FABRICATION PROCESS  
THEREOF

Examiner: OWENS, D.

\* \* \* \*

November 26, 2003

RESPONSE

Hon. Commissioner of Patents  
Washington, DC 20231

Sir:

Responsive to the Office Action dated August 28, 2003, please amend the above  
identified application as follows:

RECEIVED  
DEC - 2 2003  
TECHNOLOGY CENTER 2800